

Docket No.: 034299-654

Receipt
Jaw

APPLICANT: Simon Deleonibus, et al.
SERIAL NO.: 10/539,532
FILING DATE: June 17, 2005
TITLE: METHOD FOR FORMING PATTERNS ALIGNED ON EITHER SIDE
OF A THIN FILM
EXAMINER: Unassigned
ART UNIT: 1763

CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450, on the date printed below:

Date: 1-23-07

Name: Sharon E. Byam
Sharon E. Byam

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST TO CORRECT FILING RECEIPT

It is respectfully submitted that the Filing Receipt for the above-identified patent application has an error.

The **Foreign Applications** section is blank, but should contain the following data:

“FRANCE 02 15980 12/17/2002”

Please amend the Filing Receipt and appropriate records to reflect the correct priority information for the above-referenced patent application. A copy of the Filing Receipt is enclosed with the necessary correction indicated in red ink.

In addition, a copy of the Preliminary Amendment showing the correct priority information, as initially filed with the patent application on June 17, 2005, is enclosed as a reference.

No fee is believed to be due. However, the Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 50-1698.

Respectfully submitted,

THELEN REID & PRIEST LLP

A handwritten signature in black ink, appearing to read "Thomas Van Zandt", written over a horizontal line.

Thomas Van Zandt
Reg. No. 43,219

Dated: 1/21/08

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UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/539,532	06/17/2005	1763	900	034299-654	9	16	1

Robert E Krebs
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RECEIVED

SEP 25 2006

CONFIRMATION NO. 4554

CORRECTED FILING RECEIPT



OC000000020537479

THELEN REID & PRIEST
IP DOCKETING

Date Mailed: 09/21/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

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Bernard Previtali, Grenoble, FRANCE;
Gilles Fanget, Reaumont, FRANCE;

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Domestic Priority data as claimed by applicant

This application is a 371 of PCT/FR03/50179 12/16/2003

Foreign Applications

FRANCE 02 15980 12/17/2002

If Required, Foreign Filing License Granted: 09/21/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/539,532**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Mail log _____ Date _____
CPI _____ Date _____
Excel _____ Date _____

Reviewed By: _____ Date: _____
No Action required: _____
Action Required: _____

Early Publication Request: No

Title

Method for forming patterns aligned on either side of a thin film

Preliminary Class

216

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

Applicants also are advised that in the case of inventions made in the United States, the Director of the USPTO must issue a license before applicants can apply for a patent in a foreign country. The filing of a U.S. patent application serves as a request for a foreign filing license. The application's filing receipt contains further information and guidance as to the status of applicant's license for foreign filing.

Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Maud VINET, et al.
SERIAL NO.: unassigned
FILING DATE: herewith
TITLE: Method for Forming Patterns Aligned on Either Side of a Thin Film
EXAMINER: UNASSIGNED
ART UNIT: UNASSIGNED

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Prior to examination, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks / Arguments begin on page 3 of this paper.

Amendments to the Specification:

Please amend the specification by inserting the paragraph below, after the title on page 1.

Cross-Reference to Related Application

This application claims priority based on International Patent Application No. PCT/FR2003/050179, entitled "Method for Forming Patterns Aligned on Either Side of a Thin Film" by Maud Vinet, Simon Deleonibus, Bernard Previtali and Gilles Fanget, which claims priority of French Application No. 02/15980 filed on December 17, 2002, and which was not published in English.

REMARKS

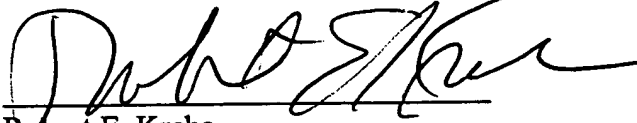
Entry of the foregoing amendment to the specification is requested to comply with the requirements of 37 C.F.R. 1.78(a)(2).

Favorable consideration and an early allowance of this application are earnestly solicited.

If the Examiner should be of the opinion that a telephone conference would be helpful in resolving any outstanding issues, the Examiner is urged to contact the undersigned.

Respectfully submitted,
THELEN REID & PRIEST LLP

Dated: Jan 16, 2005


Robert E. Krebs
Reg. No. 25,885

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